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PATENT

TC 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of Fuerhoff et al.

Art Unit 1765

Serial No. 09/502,340

Filed February 10, 2000

For METHOD AND APPARATUS FOR CONTROLLING DIAMETER OF A SILICON
CRYSTAL IN A LOCKED SEED LIFT GROWTH PROCESS

Examiner M. Anderson

December 12, 2003

AMENDMENT E

COMMISSIONER FOR PATENTS

P.O. Box 1450

Alexandria VA 22313-1450

SIR:

In response to the non-final Office action mailed September 12, 2003, please amend the application as follows:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 6 of this paper.